

***EXAMINER: Initial iteration** considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance or not considered. Include copy of this form with next communication to applicant.

POBREVO

SHEET 1 OF 1

2/25/04

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| INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i> | | Docket Number (Opt.) <u>OKI-27</u> | Application Number <u>09/825,973</u> <u>NEW</u> |
| | | Applicant(s) Norio HIRASHITA et al. | |
| | | Filing Date APRIL 5, 2001 | Group Art Unit 2823 TO BE ASSIGNED |
| EXAMINER INITIAL | OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) | | |
| JM | A | Deep sub-0.1 um MOSFET's with Very Thin SOL Layer for Ultra-Low Power Applications, Information and Communication Engineers C-II Vol. J81-C-II No. 3, pp. 313-319, August 1998. | |
| JM | B | Optimization of Series Resistance in Sub-0.2 um SOI MOSFET's, IEEE Electron Device letters, VOL. 15, No. 9, September 1994, p. 363-365. | |
| JM | C | Optimization of series resistance in Sub-0.2 um SOI MOSFET's, 1993 IEEE, pp. IEDM93-723-726-IEDM 93. | |
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| EXAMINER | DATE CONSIDERED | | |
| /Julio Maldonado/ (11/25/2006) | 11/25/2006 | | |

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